# icspi

# Motorized AFM on your benchtop

- 2 minute time-to-data
- Automatic sweep, approach & scanning
- Motorized XY and Z stages for easy sample positioning

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dux AFM

- Integrated optical microscope
- Easy-to-use tip cartridge with TipGuard

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#### **OUR MISSION**

ICSPI is on a mission to bring fast, powerful, and easy-touse nanoscale imaging tools to your benchtop.

> "I can attest that this technology is extremely reliable and can produce images that rival much larger and more expensive AFM systems."

**Professor Michael Cullinan** University of Texas at Austin, USA



### What we do

ICSPI designs and manufactures atomic force microscopes (AFMs) for research, industry and education. We push the limits of what is possible in nanoscale metrology with our team of engineers of the highest calibre working on our patented CMOS-MEMS technology. ICSPI is headquartered in Kitchener-Waterloo, Ontario, Canada.



#### **REDUX AFM**

Fast 2 minute time-to-data

Easy-to-use Scans in 3 clicks

Simple sample positioning Motorized XY and Z stages

### **Our Story**

ICSPI was founded in 2007 with the goal of bringing robust, easy-to-use, nanoscale metrology to everyone. Although technology continues to shrink faster than ever, nanoscale imaging has remained relatively inaccessible. Frustrated by the poor versatility, complexity and high costs of traditional nanoscale imaging systems, ICSPI sought to revolutionize nanoscale imaging and bring the technology to every laboratory, student and researcher.

### About the Redux AFM

- Collect 3D images at the nanoscale in 3 clicks
- Laserless system: no laser alignment
- Automatic approach: one-click automatic approach in seconds
- Unique tip cartridges and TipGuard: the only AFM with easy-to-handle tip cartridges

Simple sample positioning: motorized XY stage and integrated optical microscope

#### **REDUX AFM**

# A higher level of automation

- Automatic sweep, approach and scanning
- Motorized XY and Z stages
- Integrated optical microscope
- **Environmental cover**
- AFM tip cartridge with TipGuard



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# Unique AFM-on-a-chip Technology

#### AFM-on-a-Chip

The Redux AFM is an automated and laserless system: an integrated piezoresistive sensor allows for laser alignment-free operation and a fully automatic approach – so you can collect nanoscale data effortlessly.

All of the sensors and scanners of traditional AFM instruments have been integrated onto a single 1 mm x 1 mm chip.

"We have been blown away by its performance, ease-of-use and portability. The tool easily saves us several thousand dollars a month in AFM usage fees at third-party labs."

Dr. Michael Helander, CEO OTI Lumionics, Canada





#### Long Lifetime AFM Probe Tips

ICSPI AFM tips are made of durable materials like diamond-like carbon and aluminum oxide. Combined with the unique, compliant AFM-on-a-chip mechanism and cantilever, lifetime of 1000+ scans without noticeable wear is possible.





AFM topography scans of an Intel microchip (copper on slicion dixiode). Number indicates scan number as part of a time lapse of scans. Image quality (lateral resolution) does not degrade after over 1000 scans.

# **Redux AFM Specifications**

#### Scanning

Scan types	Topography, Phase
Max scan size	20 μm × 20 μm
Min scan size	300 nm × 300 nm
Vertical scan range	10 µm
Noise floor	<0.5 nm rms

#### **Resolution and Speed**

Quick scan (128 px)	16 sec
Routine scan (256 px)	80 sec
High-resolution scan (512 px)	5 min
Max resolution	1024 × 1024 pixels

#### Samples

Sample platform area	105 mm × 95 mm
Max sample height	20 mm
Max sample weight	250 g

#### Motorized XY Stage

Sample positioning range (XY)	10
Minimum step	<]5

#### Integrated Optical Microscope

Objective	10>
Field of view	1.4
Resolution	192
Sample illumination	Int

#### System Dimensions and Weight

Dimensions (L x W x H)	23
Weight	4

#### Software and I/O

Communication	US
Operating system	Wi
Data output	gs
Power	

Power supply	Cle
Input	100
Output	12

) mm × 10 mm
5 µm
0 25 NA
4 mm × 0.8 mm
20 × 1080 FHD Video output
tegrated LED Lighting
3.2 cm × 22.0 cm × 24.6 cm
kg
SB
/indows 10, 11
sf, tsv, png
lass II (two prong)
0-240 VAC ~ 50/60 Hz

VDC, 3 A

### Comparison

	Redux AFM	Traditional AFM	SEM
Operation in air	$\checkmark$	$\checkmark$	Х
Automatic approach	$\checkmark$	Х	N/A
Install time	5 min	1–2 weeks	1–2 weeks
Time to data	2 min	1 hr	30 min–1 hr
Cost	\$	\$\$\$	\$ \$ \$ \$
Cost per scan	\$	\$\$	\$\$
Benchtop operation	$\checkmark$	Х	Х
Training time	1 hr	12+ hrs	12+ hrs
Laser alignment-free	$\checkmark$	Х	Х
Regular power and USB	$\checkmark$	Х	Х
Easy-to-handle cartridges	$\checkmark$	Х	N/A
Maintenance-free	$\checkmark$	Х	Х
3D images	$\checkmark$	$\checkmark$	Х
Sub-nanometer resolution	$\checkmark$	$\checkmark$	Х
Non-conductive samples	$\checkmark$	$\checkmark$	Х

# Trusted by researchers, engineers and educators worldwide



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#### 1. Simple sample positioning

Using the motorized XY stage and integrated optical microscope



#### 2. Automatic approach

One-click automatic tip-sample approach completes in ten seconds



## 3D nanoscale scans in <u>3 clicks</u>

#### 3. Fast scanning

# Capture routine scans in just over a minute

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